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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No	10/695,727
Patent Application Serial No	October 28, 2003
Filing DateInventor	
Assignee	Micron Technology, Inc.
Assignee	2812
Group Art Unit	Unknown
Examiner	
Attorney Docket No	to - Chambar and Accessory
Title: Semiconductor Substrate Process	ing Chamber and Accessory
Attachment Interfacial Structure	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR § 1.8

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- 1. Certificate of Facsimile Transmission
- 2. Transmittal Form
- 3. Supplemental IDS
- 4. Form PTO-1449

5. Cited References

Dated: 11/12/2009

By:

Natalie King Telephone No. Facsimile No.

(509) 624-4276

NUMBER OF PAGES IN FACSIMILE: 30

PTO/SB/21 (03-03)

Approved for use through 04/30/2003. OMB 0851-0031 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of teformation unless it displays a valid OMB combot number. Application Number 10/895,727 Filing Date 10/28/2003 TRANSMITTAL **FORM** First Named Inventor Carpenter et al. Art Unit 2812 (to be used for all correspondence after initial filing) **Examiner Name** Unknown Attorney Docket Number MI22-2433 Total Number of Pages in This Submission **ENCLOSURES** (Check all that apply) After Allowance Communication to a Technology Center (TC) Drawing(s) Fee Transmittal Form Appeal Communication to Board Licensing-related Papers of Appeals and Interferences Fee Attached Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Pelition Amendment/Reply Petition to Convert to a Proprietary Information Provisional Application After Final Power of Attorney, Revocation Stelus Leller Change of Correspondence Address Affidavils/declaration(s) Other Enclosure(s) (please Terminal Disclaimer Identify below): Extension of Time Request Form PTO-1449; Cited References Request for Refund Express Abandonment Request CD, Number of CD(s) Information Disclosure Statement Remarks Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm Mark S. Matkin, Reg. No. 32,268 Wells St. John P.S. Of Individual Signature Date CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facalmile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mall in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on this date: **・ノ**ス・Z0c/Y Typed or printed Natalie King 11-12-2004 Date Signature This collection of information is required by CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentially a governed by 36 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete. Including gathering, proparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form a fidor suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commercia, Washington, DC 20231. OO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, CC 20231. If you need assistance in completing the form, call 1-809-PTO-9189 (1-800-786-9199) and select option 2.

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Assignee	Micron Technology, Inc.
Group Art Unit	2812
Examiner	Unknown
Attorney's Docket No	MI22-2433
Title: Semiconductor Substrate Processing Cr	namber and Accessory Attachment
Interfacial Structure	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT References - See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to 1273 OG 55, August 5, 2003, no copies of cited U.S. patents or U.S. patent application publications are included, as the date of filing of this patent application occurs after June 30, 2003. Copies of all other art are attached hereto. No admission is made regarding whether all the listed references are prior art.

This Supplemental Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing of a first Office Action on the merits, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 11-12-64

Mark S. Matkin, Reg. No. 32,268

Form PTO-1449

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

LIST OF ART CITED BY APPLICANT
(Use poveral sheets it necessary)

ATTY. DOCKET NO. 10/695,727

APPLICANT: Craig M. Carpenter et al.

FILING DATE October 28, 2003

GROUP
2878

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